

L Number	Hits	Search Text	DB	Time stamp
-	3904	antireflective	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:32
-	1207	microlithographic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 11:08
-	83	antireflective and microlithographic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 11:08
-	53	((antireflective and microlithographic) and acid	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 08:20
-	14	((antireflective and microlithographic) and acid) and (bisphenol or acetic adj acid or cinnamic)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 08:21
-	3904	antireflective	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 11:08
-	1207	microlithographic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 11:08
-	83	antireflective and microlithographic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/06/17 11:08
-	483380	anti	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:32
-	1	spin adj bowl adj compatibility	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:32
-	11014	antireflective or anti-reflective	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:33
-	1	spin adj bowl adj compatibility	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:34
-	57578	bisphenol adj a	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:34
-	1173	\$hydroxycinnamic adj acid	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/05 08:35

-	0 (antireflective or anti-reflective) and (hydroxycinnamic adj acid)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:35
-	1 (antireflective or anti-reflective) and (\$hydroxycinnamic adj acid)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:35
-	176 alpha-cyano-4-hydroxycinnamic adj acid	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:36
-	0 (antireflective or anti-reflective) and (alpha-cyano-4-hydroxycinnamic adj acid)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:41
-	218 (antireflective or anti-reflective) and (bisphenol adj a)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:42
-	1431 microlithographic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:43
-	4520 microlithography or microlithographic	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:44
-	330 (microlithography or microlithographic) and (antireflective or anti-reflective)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:44
-	51 ((microlithography or microlithographic) and (antireflective or anti-reflective)) and (bisphenol adj a)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2003/03/05 08:44